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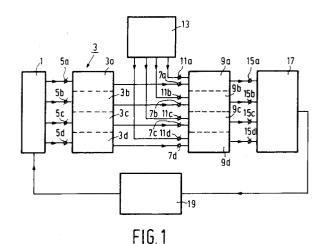
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9 Power supply apparatus.

57) The power supply apparatus for supplying a device (1) with electric energy comprises at least two test inputs (5a, ..., 5d) for receiving test signals which are dependent on a variable which itself is dependent on a power applied to the device. Each test input (5a, ..., 5d) is connected to a first input of an associated comparator circuit (9a, ..., 9d), the second input (11a, ..., 11d) of which is connected to a generator (13) for generating a number of reference signals which corresponds to the number of test inputs, said reference signals representing the desired values of said variables. The outputs of the comparator circuits (9a, ..., 9d) are connected to a control member (17) which is adapted to control the power applied to the device (1) by the power supply apparatus so that at least one of the variables is essentially equal to the desired value, the other variables deviating from the desired value in a predetermined sense only.



EUROPEAN SEARCH REPORT

EP 92 20 0760

Category	Citation of document with in of relevant pa	dication, where appropriate, ssages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int. Cl.5)
4	* column 2, line 55	ELMETAL ELECTRO GMBH) - line 60 * - column 5, line 1;	1,4	G05F1/46 G05F1/575 H01S3/133 H01S3/00 G05F1/66
D,A	PHILIPS TECHNICAL R vol. 39, no. 2, 198 pages 37 - 47 J.C.J. FINCK ET AL. for Information Rea * figure 14 *	O, EINDHOVEN, NL 'A Semiconductor Laser	1,4	4031 17 00
1	PATENT ABSTRACTS OF vol. 10, no. 27 (E-& JP-A-60 187 074 (September 1985 * the whole documents	378)(2084) 2 April 1986 TOSHIBA K.K.) 24	1	
A	US-A-4 019 105 (COR * column 1, line 53 * column 3, line 59 figures *	NELL ET AL.) - column 2, line 16 * - column 4, line 62;	1	TECHNICAL FIELDS SEARCHED (Int. Cl.5)
				G05F H01S
	The present search report has b	een drawn up for all claims		
Place of search THE HAGUE 3		Date of completion of the search 30 MARCH 1993		Examiner SAAW L.J.
X:par Y:par doc	CATEGORY OF CITED DOCUMENT ticularly relevant if taken alone ticularly relevant if combined with and ument of the same category hnological background	E : earlier patent do after the filing d	cument, but pub ate n the applicatio or other reasons	lished on, or n